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862.C1811

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

: Examiner: Unassigned

TADAHIRO OHMI, ET AL.

Application No.: 09/494,945

Filed: February 1, 2000

For: LASER OSCILLATING
APPARATUS, EXPOSURE
APPARATUS USING THE SAME,
AND DEVICE FABRICATION
METHOD

June 2, 2000

The Assistant Commissioner for Patents Washington, D.C. 20231

CLAIM TO PRIORITY

Sir:

Applicants hereby claim priority under the International Convention and preserve all rights to which they are entitled under 35 U.S.C. § 119 based upon the following Japanese Priority Applications:

JAPAN 11-023902, filed February 1, 1999;

JAPAN 11-051807, filed February 26, 1999;

JAPAN 11-051808, filed February 26, 1999;

JAPAN 11-051809, filed February 26, 1999;

JAPAN 11-051810, filed February 26, 1999;

JAPAN 11-051812, filed February 26, 1999; and

JAPAN 11-051813, filed February 26, 1999.

Certified copies of the priority documents are enclosed.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

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JJO/tmm